Attorney Docket No.: 16869P-041600US
Client Reference No.: 210100219US1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Mineo Nomoto, et al.

Application No.:

Filed: Herewith

For: Method and Apparatus for Measuring Thickness of Thin Film and Device Manufacturing Method

**Using Same** 

Examiner:

Unassigned

Art Unit:

Unassigned

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97 and §1.98

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

The references cited on attached form PTO/SB/08A are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

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Mineo Nomoto, et al. Application No.: Page +

Respectfully submitted,

Robert C. Colwell Reg. No. 27,431

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ON DIS	CLOSURE	Filing Date				
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U.S. PATENT DOCUMENTS						
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Examiner Initials *	Cite No. <sup>1</sup>	Number	Kind Code <sup>2</sup> (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA		1			
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		Office <sup>3</sup>	Number⁴	Kind Code <sup>5</sup> (if known)	or Applicant of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	T <sup>6</sup>
	AU	JP	2000-310512	:	Hitachi, Ltd.	11-07-2000		Abstract
	AV	JP	2000-077371		Nikon Corp.	03-14-2000		Abstract
	AW	JP	10-294297		Nikon Corp.	11-04-1998		Abstract
	AX	JР	10-083977		Applied Materials	03-31-1998		Abstract
	AY	JР	09-007985		Applied Materials	01-10-1997		Abstract
	AZ	JP	06-252113		Matsushita Electric	09-09-1994		Abstract
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